What is claimed is:

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- 1. A probe apparatus comprising:
- a mounting member on which an object to be inspected is mounted, a temperature of the object being adjusted by the mounting member;
 - a probe card arranged opposite to the mounting member;
- a driving mechanism which changes the relative positional relationship between the mounting member and the probe card; and
- a sensor which detects the distance between the sensor and the probe card.
- 2. The probe apparatus of claim 1, wherein the sensor is a laser displacement sensor or a capacitive sensor.
 - 3. The probe apparatus of claim 1, wherein the driving mechanism moves the mounting member in X, Y and Z directions.
- 20 4. The probe apparatus of claim 1, wherein the sensor is attached to the driving mechanism.
 - 5. The probe apparatus of claim 4, wherein the sensor is a laser displacement sensor or a capacitive sensor.
 - 6. The probe apparatus of claim 4, wherein the driving

mechanism moves the mounting member in X, Y and Z directions.

- 7. The probe apparatus of claim 1, wherein the sensor is provided at a part of the apparatus to which the probe card is fixed.
 - 8. The probe apparatus of claim 7, wherein the sensor is a laser displacement sensor or a capacitive sensor.
- 9. The probe apparatus of claim 7, wherein the driving mechanism moves the mounting member in X, Y and Z directions.
 - 10. The probe apparatus of claim 1, wherein the sensor is installed on the mounting member.
 - 11. The probe apparatus of claim 10, wherein the sensor is a laser displacement sensor or a capacitive sensor.
- 12. The probe apparatus of claim 10, wherein the driving 20 mechanism moves the mounting member in X, Y and Z directions.

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